#### LWIR DETECTOR RESEARCH IN InAsSb/InAs

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The InAsSb/InSb strained-layer system forms a type-II superlattice in the Sb-rich region of the phase diagram. The band gap of InAsSb/InSb strained-layer superlattices grown on lattice-matched buffers can be varied continuously to produce semiconducting systems with band gaps ranging from that of InSb (0.23 eV with an absorption edge at 5.5 µm at 77 K) to 0. The semiconductor to semimetal transition occurs at As concentrations of approximately 30 %, with the precise value dependent upon the strain and quantum well dimensions. At higher As content, the system is a semimetal. We have fabricated photovoltaic detectors with high D\* at 77 K at wavelengths beyond 10 µm, and both photovoltaic and photoconductive detectors have been demonstrated with response to 15 µm. The photoconductive detectors exhibit gain of up to 100. This talk will discuss details of the materials growth, studies of the band structure and properties, device processing and the detector performance observed to date in these systems.

## LWIR DETECTOR RESEARCH IN InAsSb

## P. S. Peercy

# Sandia National Laboratories Albuquerque, New Mexico

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### **OUTLINE**

- Summary of InAsSb SLS Properties
   Band structure
   Optical properties
- Photoconductive Detectors
   High gain type II superlattices
- Photovoltaic Detectors

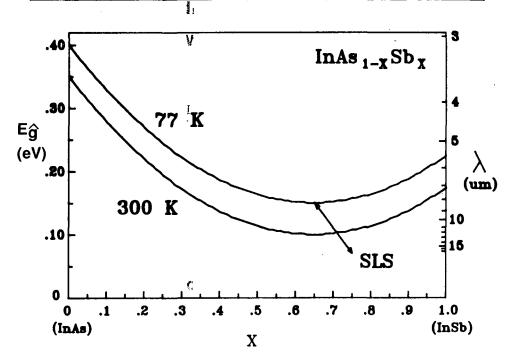
Electrical characteristics

Detector response

- Extension to wavelengths beyond 10  $\mu\text{m}$
- Process Monitors and control REMS for on-line growth control
   PL for monitoring material quality
   Processing issues
- Summary

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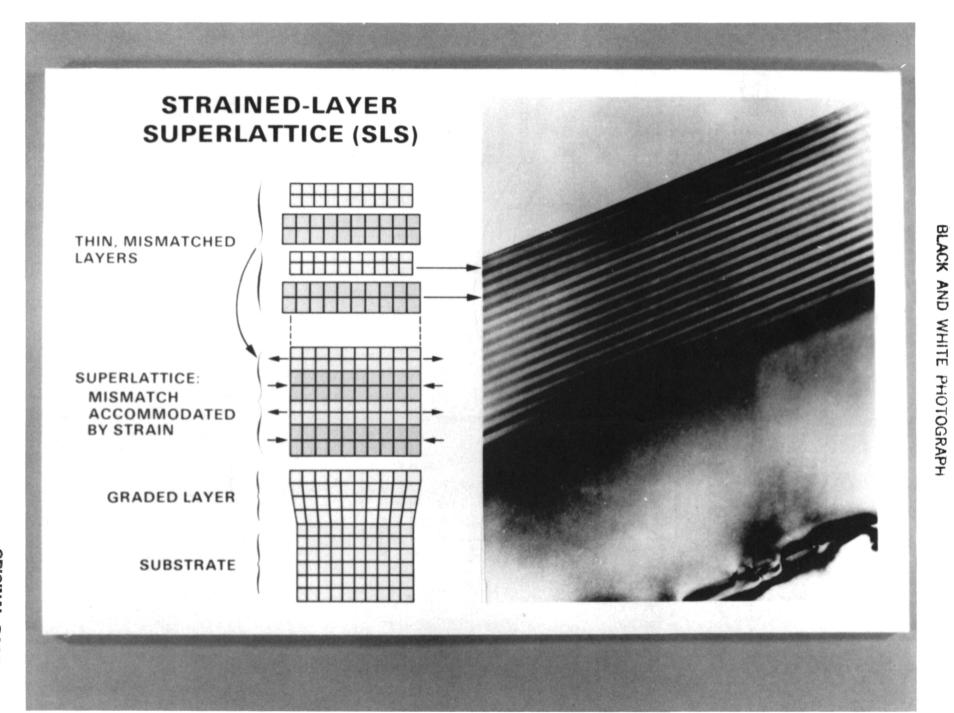
## ENERGY GAP IN THE InAsSb ALLOY SYSTEM



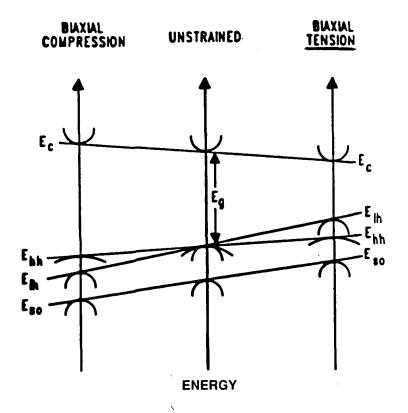
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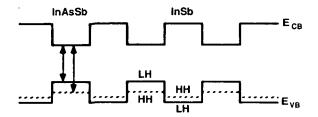


ORIGINAL



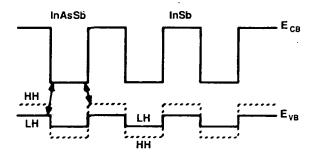
### TYPE I OFFSET:

(Spatially "direct", low energy transitions)

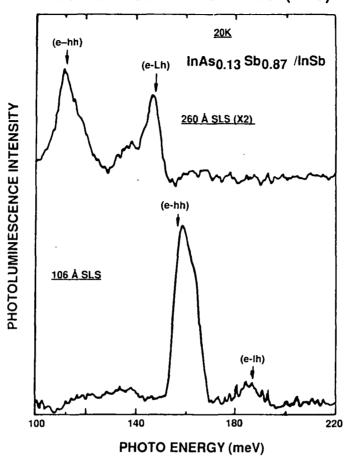


### **TYPE II OFFSET:**

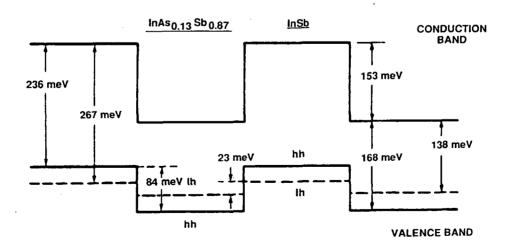
(Lower energy, spatially "indirect" transitions)



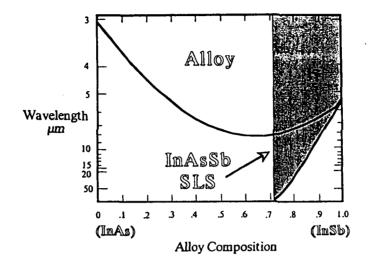
### Infrared Photoluminescence (SLS)



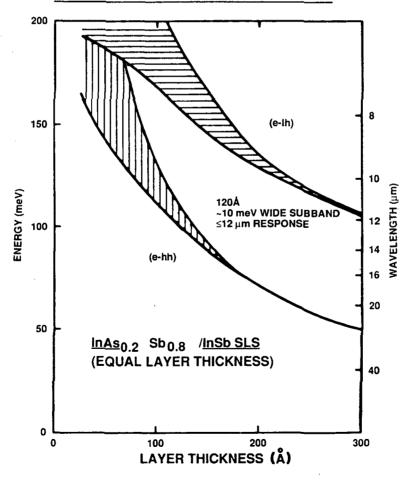
## QUANTUM WELL STRUCTURE FROM PL DATA



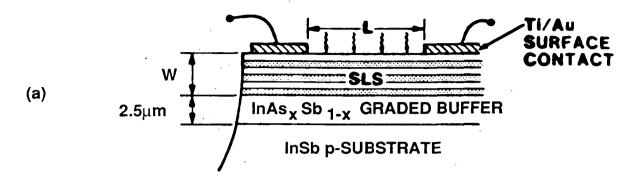
Far IR Wavelength Accessibility of SLS InAsSb Detectors at 77K

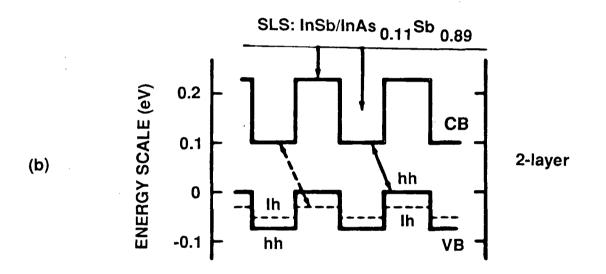


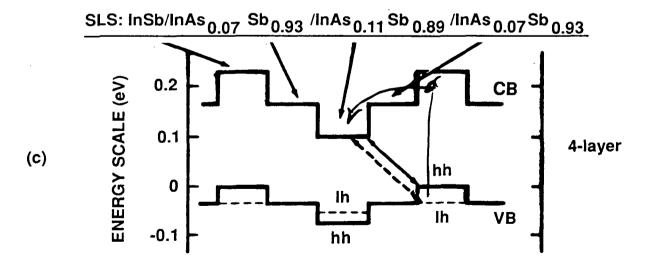
**N=1 Transitions For 20% As SLS** 



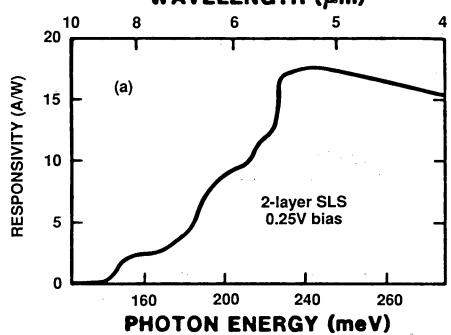
## **InAsSb SLS Photoconductive Detector**

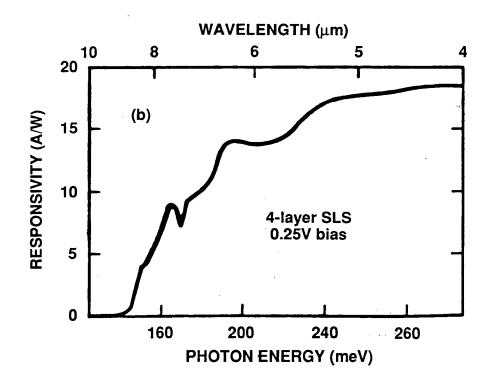


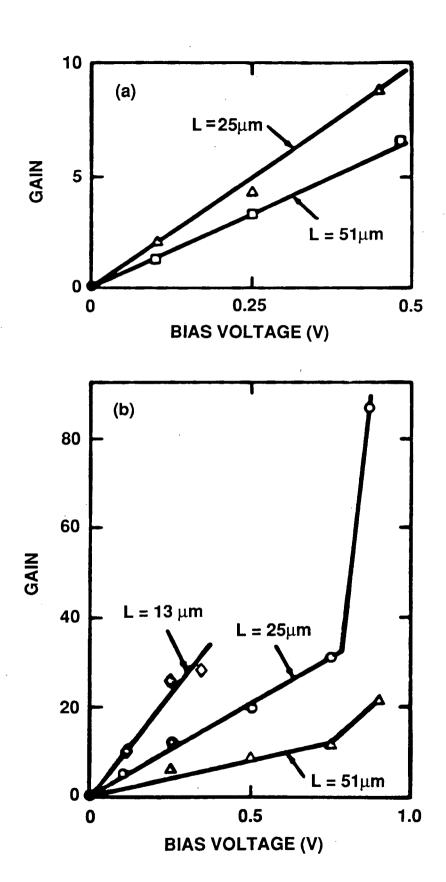




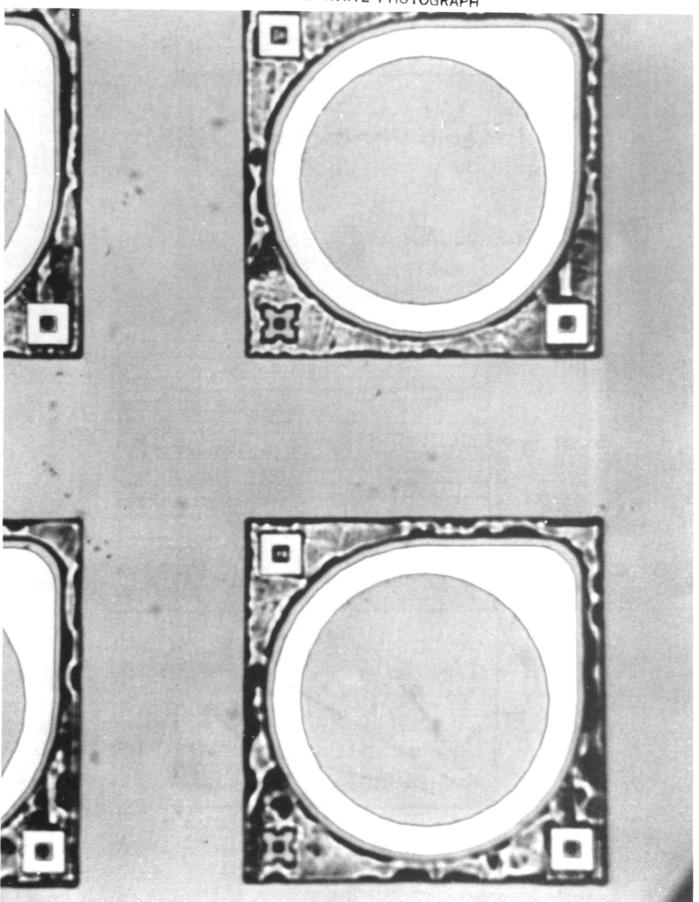
# Photoconductive Detector Responsivity **WAVELENGTH (μm)**







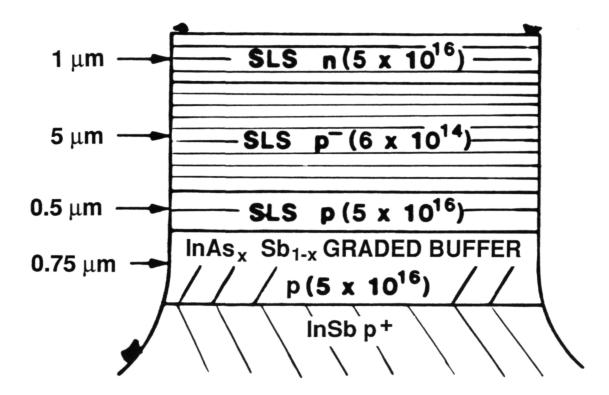
ORIGINAL PAGE BLACK AND WHITE PHOTOGRAPH

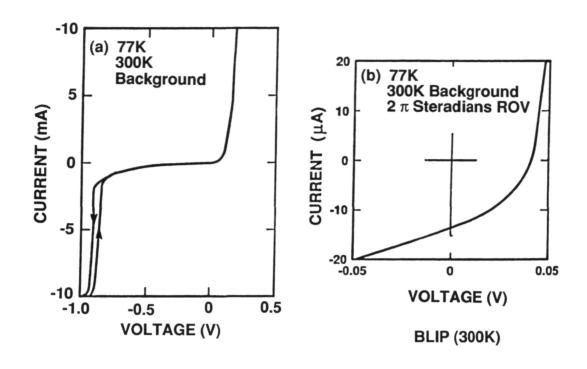


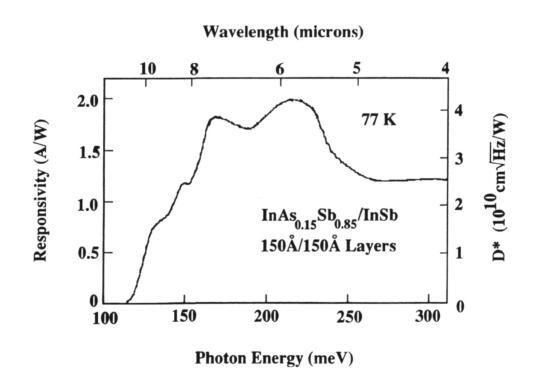
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## InAsSb Photodiode (MBE)

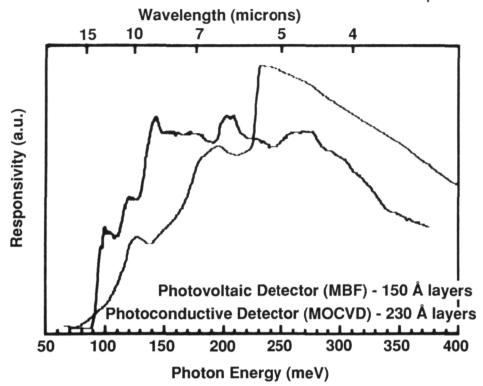
SLS: 200Å InAs $_{0.15}$  Sb $_{0.85}$ /200Å InSb







## PHOTOVOLTAIC AND PHOTOCONDUCTIVE SLS DETECTOR PHOTORESPONSE TO 15 $\mu\text{m}$



### **PROCESS CONTROLS**

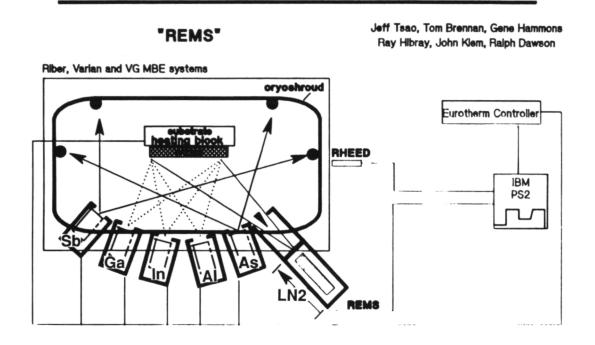
On-line monitors and control during growth

REMS (MBE)

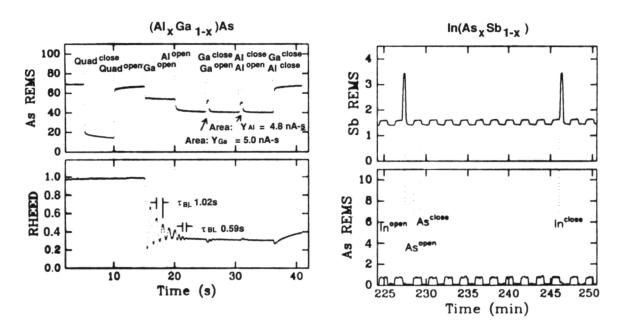
UV absorption (MOCVD)

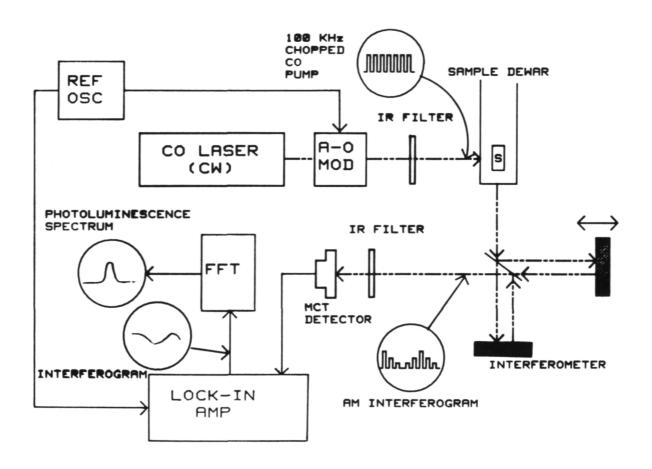
Monitor of superlattice quality
 Photoluminescence

### Reflection Mass Spectometry and III/V MBE

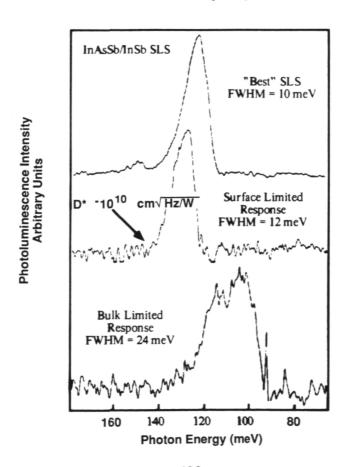


## Composition Control using REMS





Photoluminescence Linewidth Characterization of Wafer Quality



### PROCESSING TECHNIQUES

ETCHING - STANDARD WET-CHEMICAL TECHNIQUES USING STANDARD PHOTORESIST PROCESSES

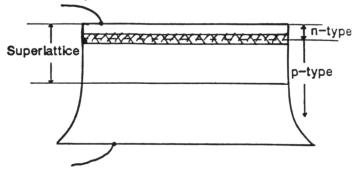
METALLIZATION - NON-ALLOYED TI/Au OR Cr/Au OHMIC CONTACTS DEFINED BY CONVENTIONAL LIFTOFF TECHNIQUES

PASSIVATION - VARIOUS SCHEMES ARE BEING INVESTIGATED WITH POSITIVE RESULTS

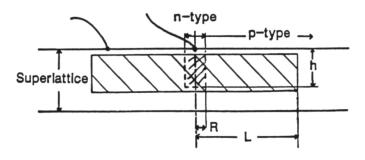
PACKAGING - STANDARD PACKAGES AND ADHESIVES WITH ULTRASONIC LEAD BONDING HAVE BEEN USED SUCCESSFULLY

INTERFACING - ISSUE NOT ADDRESSED YET

### Superlattice Mesa Photodiode:



### Lateral Superlattice Photodiode:



### SUMMARY

- InAsSb SLS detectors can span the 8-15  $\mu$ m spectral region
- LWIR photovoltaic detectors have been demonstrated with D\* > 1010 cm $\sqrt{\text{Hz/W}}$  at 10  $\mu\text{m}$
- LWIR photoconductive detectors with high gain have been demonstrated
- REMS and PL have been demonstrated to be valuable growth and process monitors